



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kazuhiko FUKAZAWA et al.

Group Art Unit: 2829

Application No.: 10/807,262

Examiner: E. KARLSEN

Filed: March 24, 2004

Docket No.: 119216

For: SUBSTRATE INSPECTION SYSTEM, SUBSTRATE INSPECTION METHOD, AND
SUBSTRATE INSPECTION APPARATUS

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the February 20, 2007 Office Action, the shortened statutory period for
reply being extended by the attached Petition for Extension of Time, please consider the
following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.